

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 10, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG668471532

LABORATORY GROWN DIAMOND

EMERALD CUT

7.58 X 5.34 X 3.62 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.51 CARAT

E

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

VERY GOOD

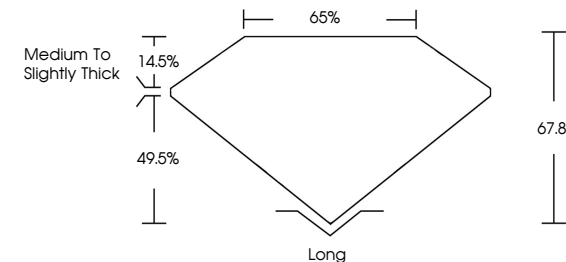
NONE

Inscription(s)

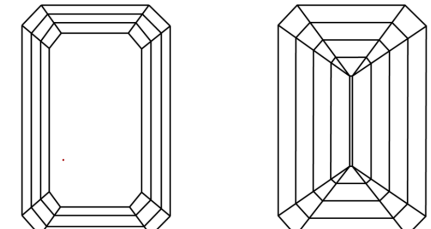
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG668471532

PROPORTIONS



CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY


D	E	F	G	H	I	J	Faint	Very Light	Light
IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³					
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included					



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
EXCELLENT

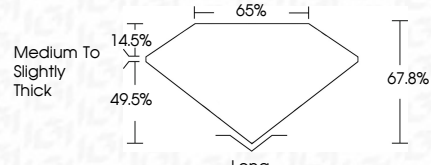
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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.51 CARAT

E

VVS 2

67.8%

65%

Long

EXCELLENT

VERY GOOD

NONE

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